

Atomic Force Microscopy





Illinois Materials Research Lab Central Research Facilities

- User facility—anyone can be trained
 - UIUC and non-UIUC researchers welcome
 - Undergraduate researchers welcome
 - Staff collaboration or analysis available
- mrl.illinois.edu/facilities
- mrl-facilities@illinois.edu

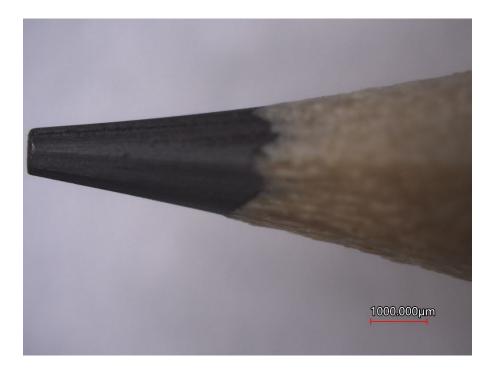


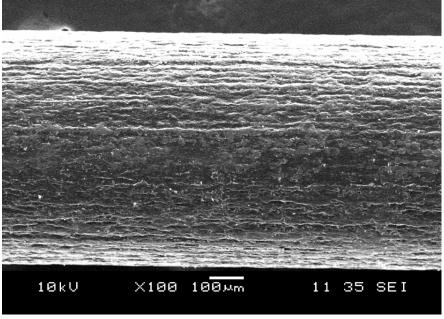


Looking at Surfaces

Optical Microscopy

Scanning Electron Microscopy



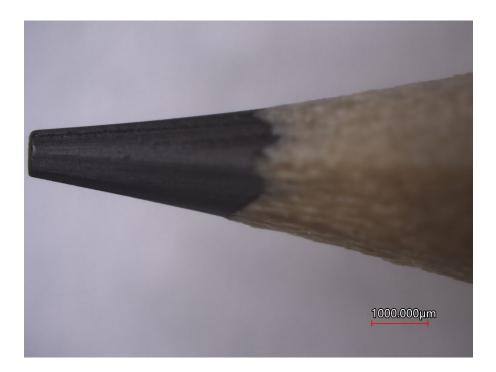


mechanical pencil "lead"

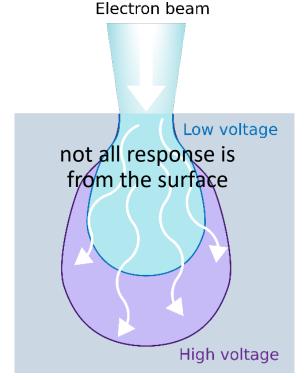


Looking at Surfaces

Optical Microscopy



Scanning Electron Microscopy



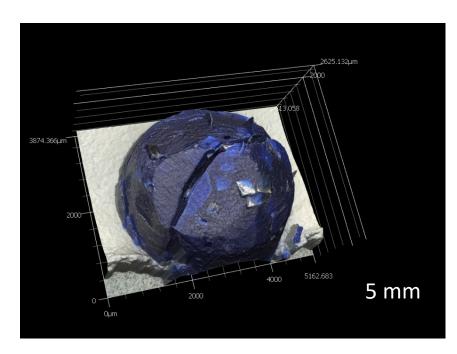
Adapted from https://myscope.training/#/SEMlevel_2_13 (CC BY-SA 4.0)



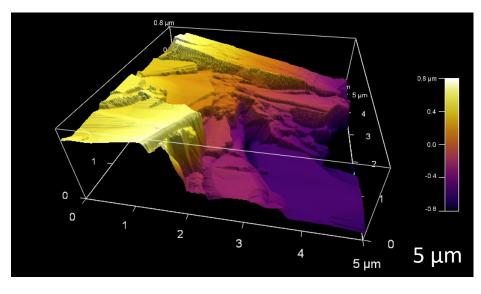
Surface XYZ Coordinates Needed

3D Optical Profilometry

Atomic Force Microscopy



blue glitter crayon tip



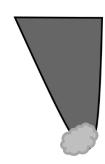
pencil "lead"

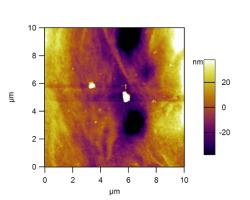


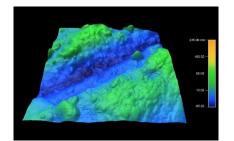
Topics for Today

How AFM works

- Featured applications
 - Topography
 - Profiles, step height
 - Roughness
 - Phase
 - Conductive AFM
- Issues and artifacts
- Image processing



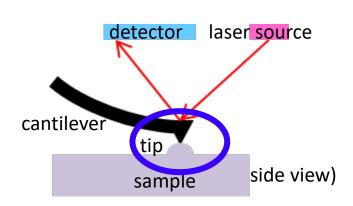


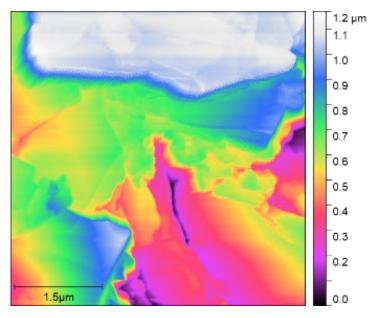




What's an Atomic Force Microscope?

"Atomic Force" Microscopy—forces between atoms in the tip and atoms in the sample



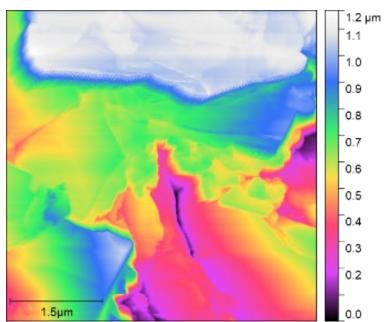


false-color surface topographs

I

What's an Atomic Force Microscope?

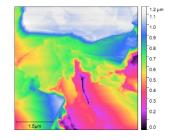
- "Atomic Force"—interactions between tip and sample
 - Not actual atomic resolution (usually)
 - Nanoscale lateral resolution (depends on tip)
 - Sub-angstrom vertical resolution
- "Microscope"—surface topograph (false color)





What's an Atomic Force Microscope?

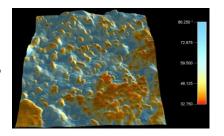
- "Atomic Force"—interactions between tip and sample
 - Sub-angstrom vertical resolution
 - Not actual atomic resolution (usually)
 - Nanoscale lateral resolution (depends on tip)
- "Microscope"—surface topograph (false color)



- Tip at the end of a cantilever
- Raster tip over surface to build up an image



 Also sensitive to sample stiffness, adhesion, other properties depending on tip choices



Turquoise, 1μm x 1μm color overlay: phase



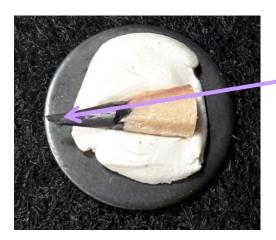
Typical AFM Scales

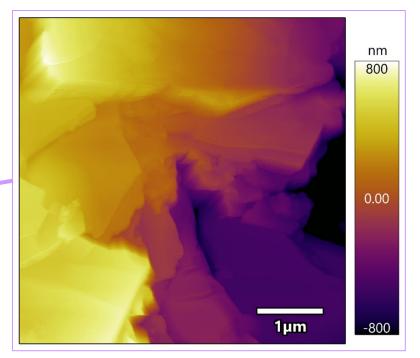
(only what's pretty common, not all of what's possible)

- Image sizes -- few to tens of μm²
- Feature peak-to-valley -- Å to μm



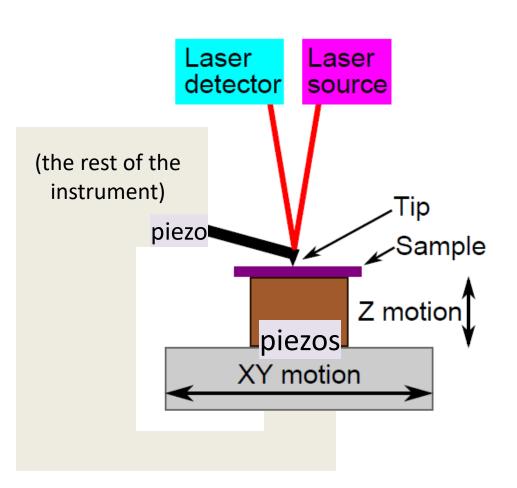
- Sample sizes -- mm to cm
- AFM measures surfaces

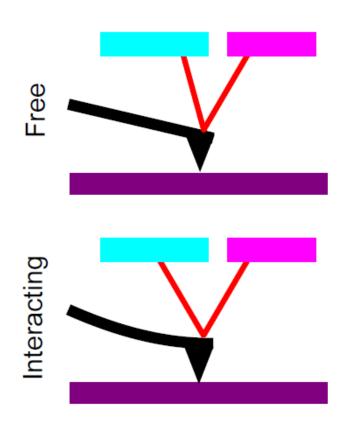






AFM Schematic



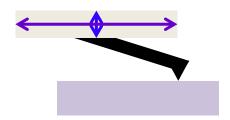




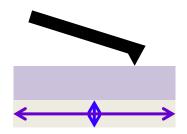
Scanners

scanning probe microscopy

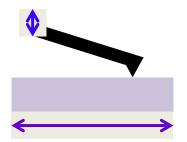
tip scanning



sample scanning



decoupled scanning

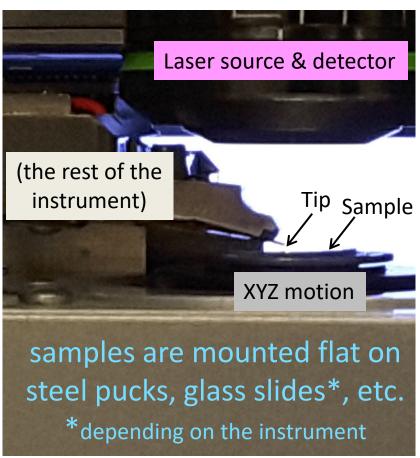


tapping is done close to or at the cantilever (tapping mode will be discussed later)

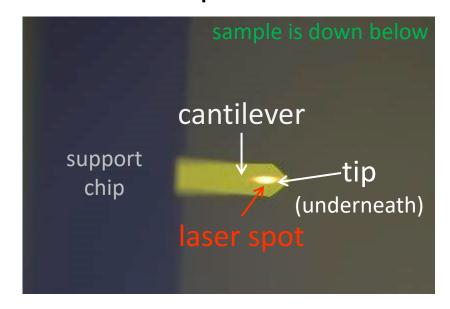




AFM Instrument



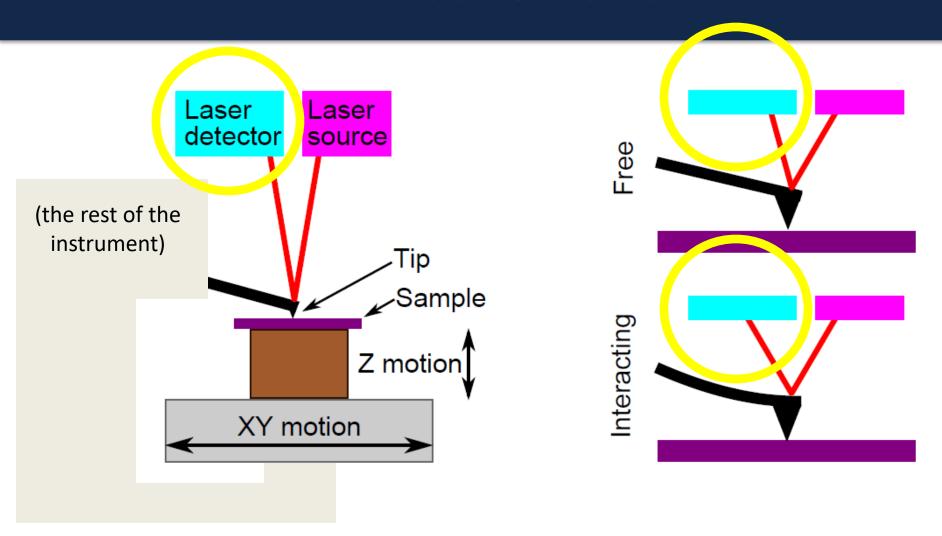
top view



side view

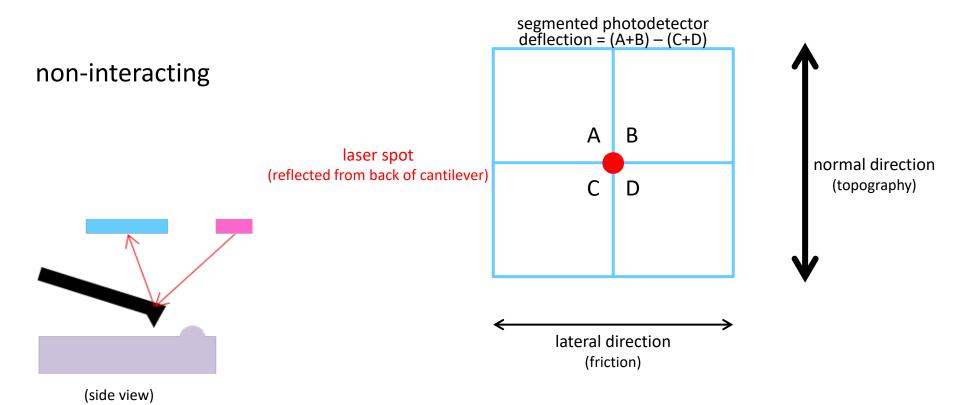


AFM Schematic



I

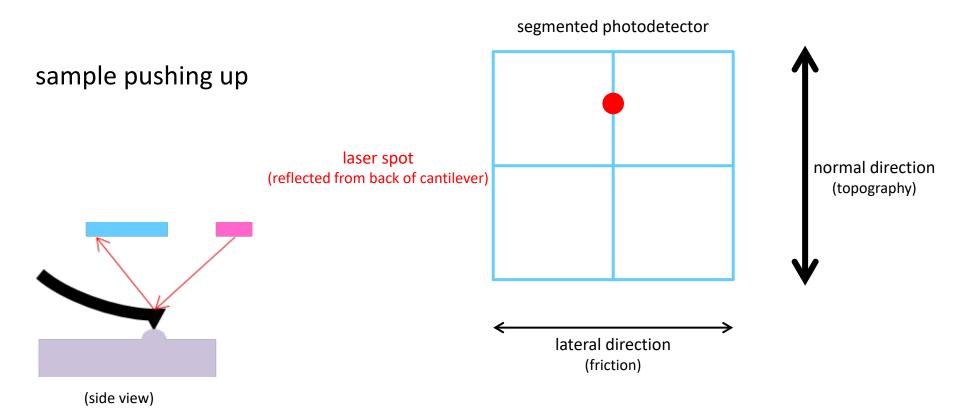
Laser Detection



(exaggerated schematic)

I

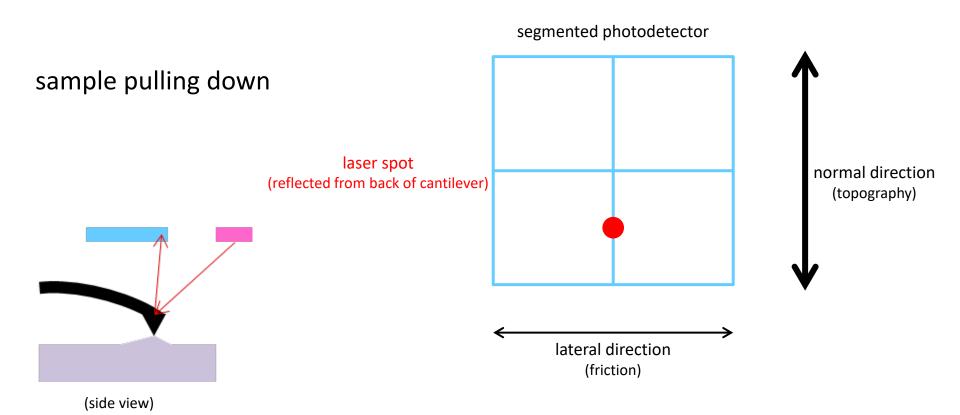
Laser Detection



(exaggerated schematic)

П

Laser Detection

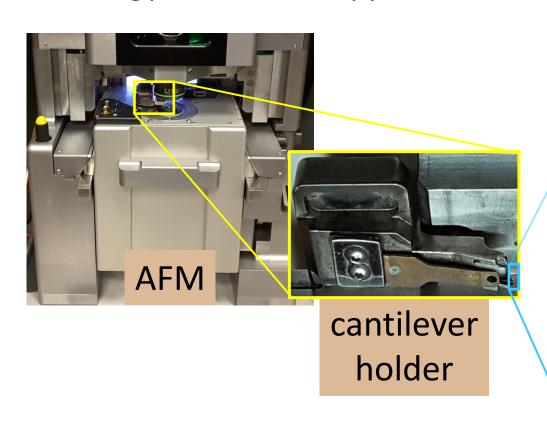


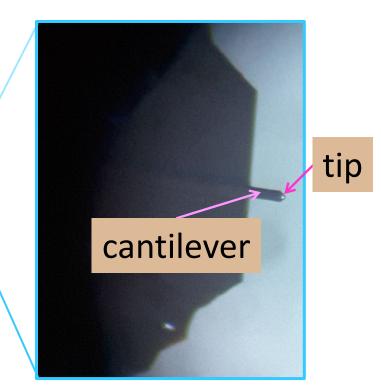
(exaggerated schematic)



AFM Tips

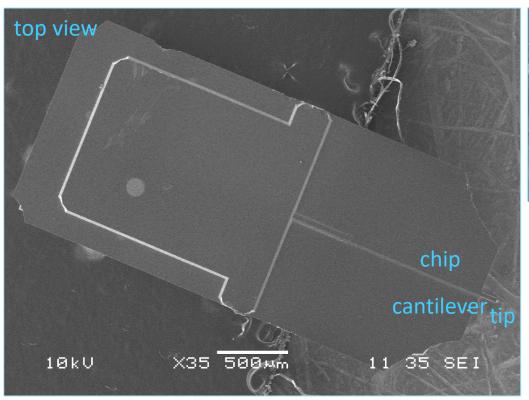
scanning probe microscopy



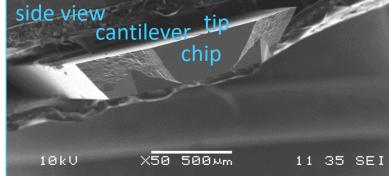




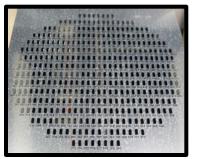
Tip Terminology



"probe"

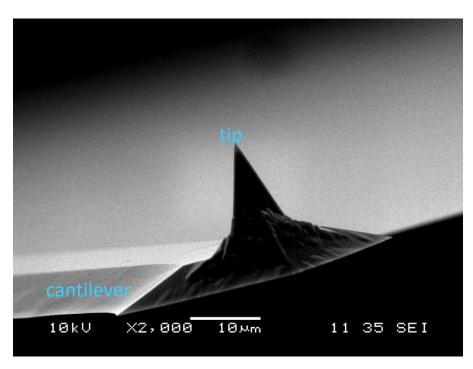


tips point upwards in the box

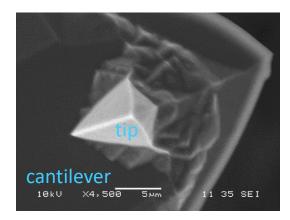


SEM images taken using MRL's JEOL 6060LV

Typical Tip



SEM images taken using MRL's JEOL 6060LV



common tip for imaging:

- tip radius of curvature < 10 nm
- silicon tip
- cantilever width 30 μm
- cantilever length 125 μm
- cantilever thickness 4 μm



Tip Types

- Typical tapping tip cost ~\$21
- Specialized tips cost more
 - Coatings (electrical, magnetic) usually a couple more dollars per tip
 - Ultrasharp tips ~\$80-200
 - Coaxial microwave waveguide tips ~\$150

The ultimate probes for

bestsellers

electrical characterization

geometry for

» new

nanomechanics

Colloidal probes, coated tips, made-to-order probes available



systems

★ bestsellers

The Nanotech Facilitator

Temperature and thermal

conductivity measurements



"How long does a tip last?"

- Tips are consumables
 - Contamination from samples
 - Wear from samples
 - Dropping them



- When your tip goes bad, just throw it out!
- Generally come in 10-packs
 - 50-packs if you scan a whole lot

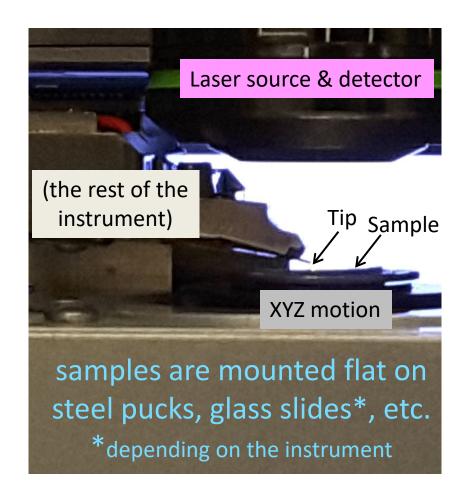




The Process

- Mount tip
- Mount sample
- Scan
- Process image
- Extract numbers

 (application-dependent)

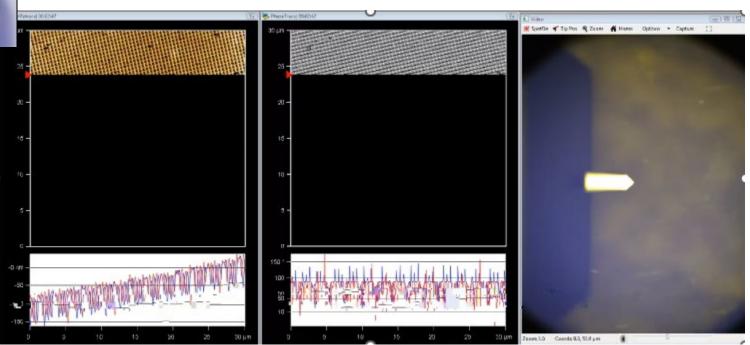




Raster Scanning



Move probe and sample with respect to one another to build up an image





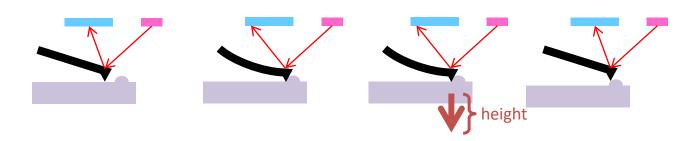
Feedback





Feedback

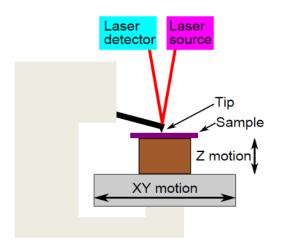
- z piezo extension adjusted to keep feedback signal equal to setpoint
 - too much force—move away
 - too little force—move closer
 - deflection for contact mode, usually amplitude for tapping mode
- distance extended or retracted describes the height of the feature

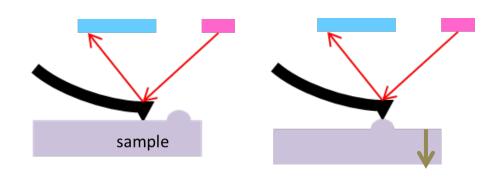




Contact Mode Imaging

- Drag tip along surface like a stylus profilometer (or like a record player)
- Adjust tip—sample separation to keep cantilever deflection constant
 - Traces sample topography
 - Some AFMs move tip;
 some move sample

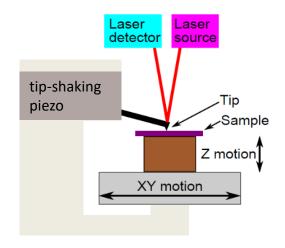




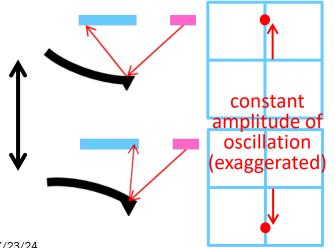


Tapping Mode Imaging

- Standard mode for AFM topography
- Intermittent contact, tapping, AC, amplitude modulation mode
- Not constantly in contact with the surface
- Driven, oscillating cantilever
- Tip—sample interactions affect oscillation

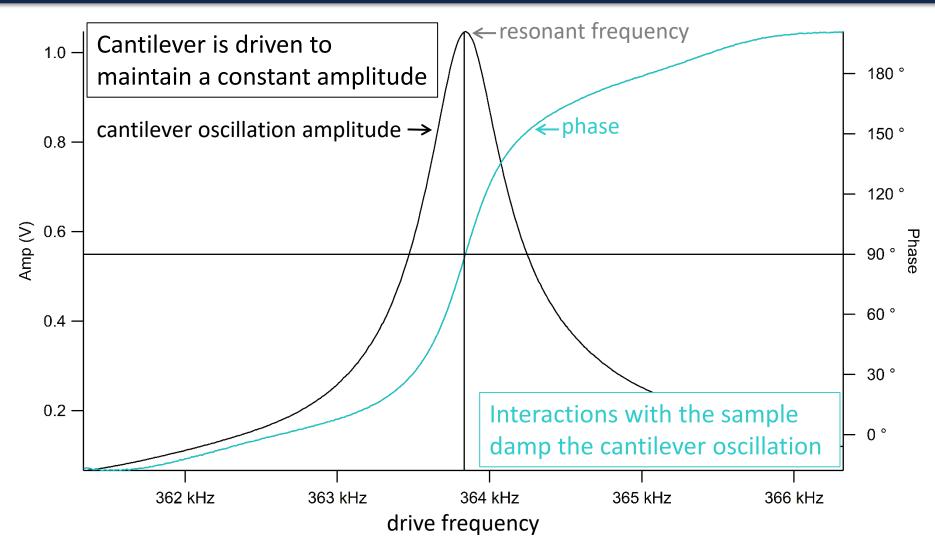


tip oscillates at tens of kHz to MHz

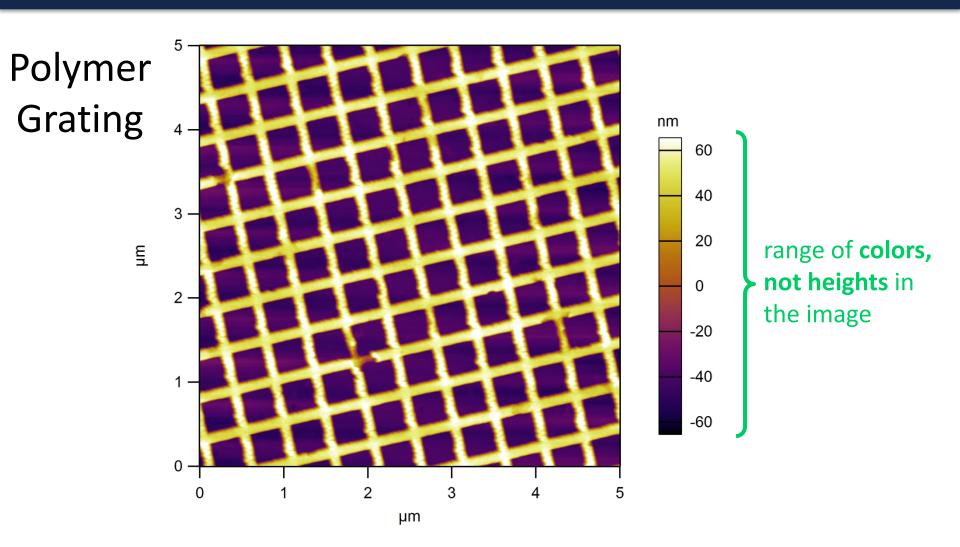




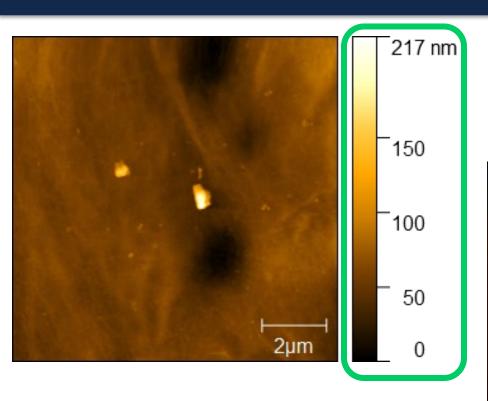
Tuning the Cantilever



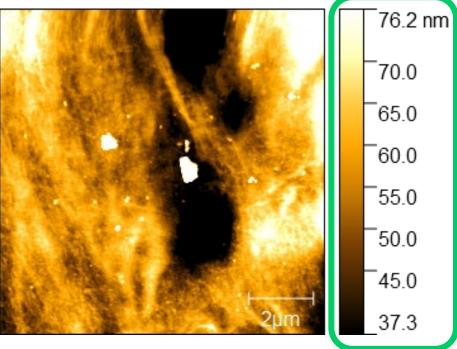








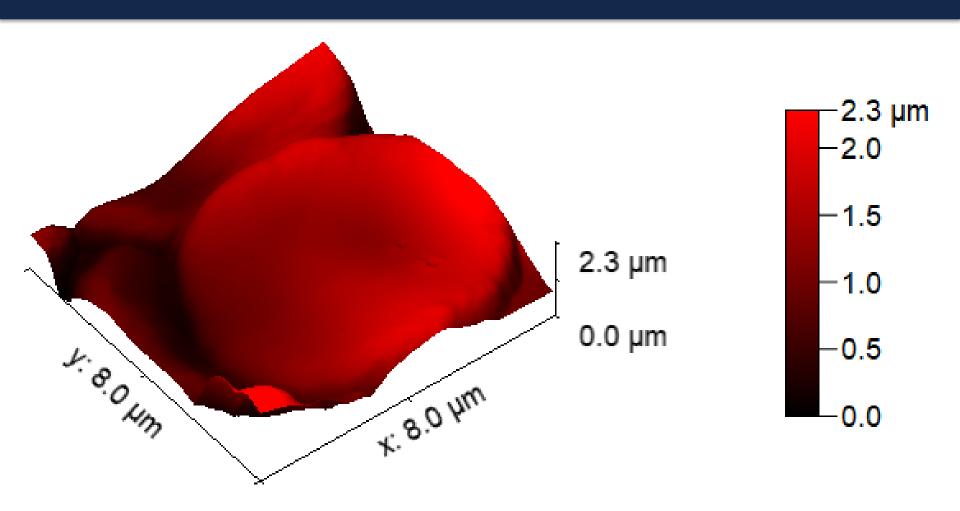
same image, different color ranges
color range of the displayed image,
not necessarily all heights on the surface



BOPP/PE polymer blend (toothbrush packaging), 10μm x 10μm AFM topograph



Interpreting 3D Images



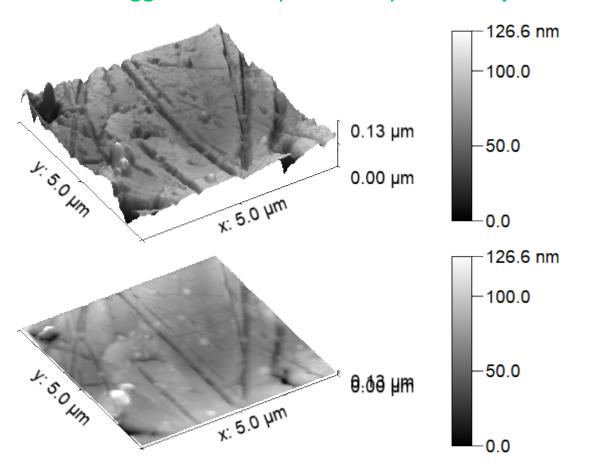
blood cells, 8µm x 8µm AFM topograph



Interpreting 3D Images

not necessarily 1:1:1 z:x:y

z often exaggerated compared to xy to convey texture information

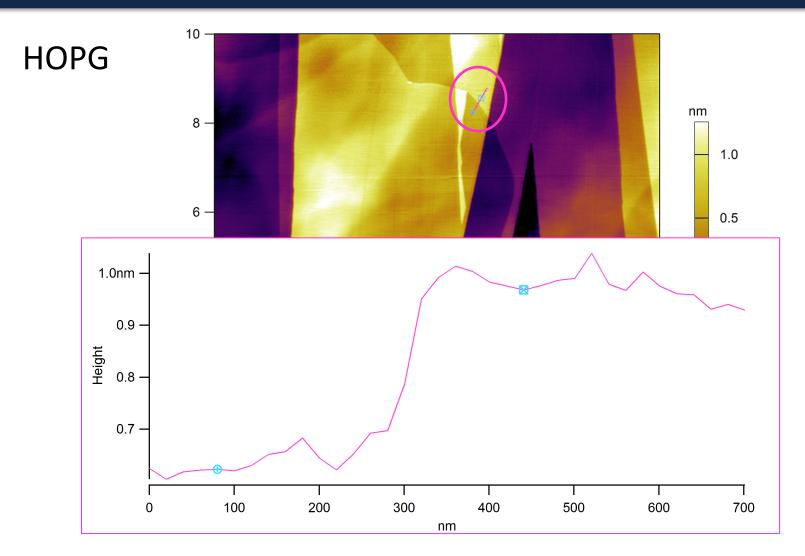


steel sample disk 5µm AFM topograph

(samples courtesy of Physics 403 Lab 2022)



Application: Step Heights

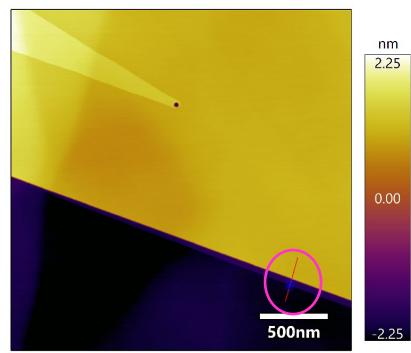


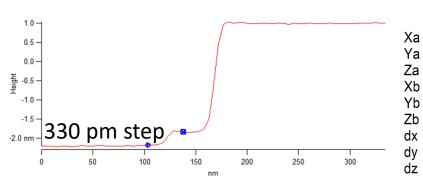


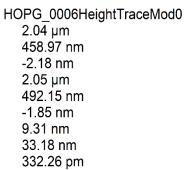
Application: Step Heights

HOPG

(highly oriented pyrolytic graphite)



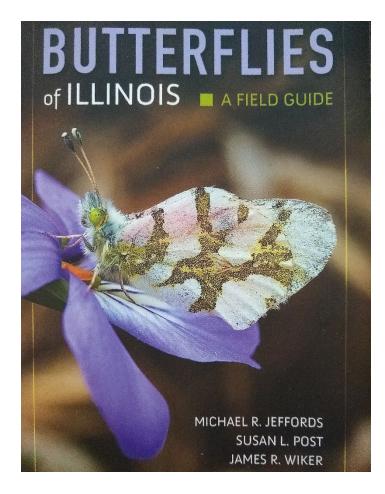


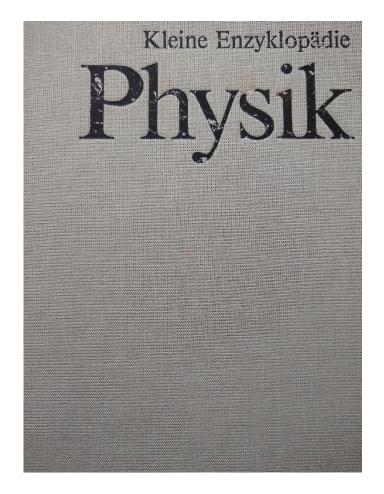




Step Heights and Thicknesses

Which book is thicker?

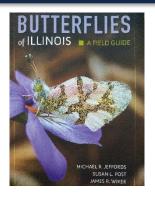


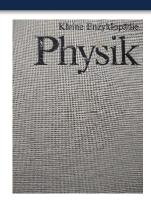




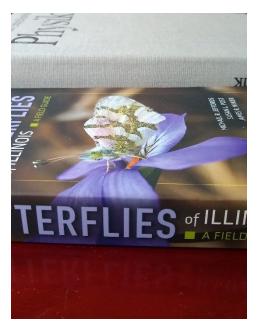
Step Height: Relative Height

 Film thickness is measured by step height





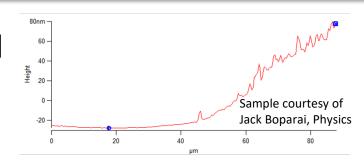
- Measure a height difference
 - Leave some bare substrate (patches are OK)
 - Scratch down to the substrate
 - Multilayer material—exposed underlayer





Step Height/Film Thickness: Complementary Techniques

If your step's too broad for the AFM (edge width >~80um), try...



- Stylus profilometry
- 3D optical profilometry

Need a height difference (step) like AFM

- X-ray Reflectivity (XRR)
- Rutherford Backscattering Spectrometry (RBS)

Continuous film (no steps)
May need to know density

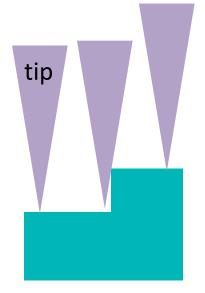


Width Measurements

Beware of tip shape convolution

- As depth increases, tips get broader
- Steep drop-offs look less sharp
- High aspect ratio tips are available

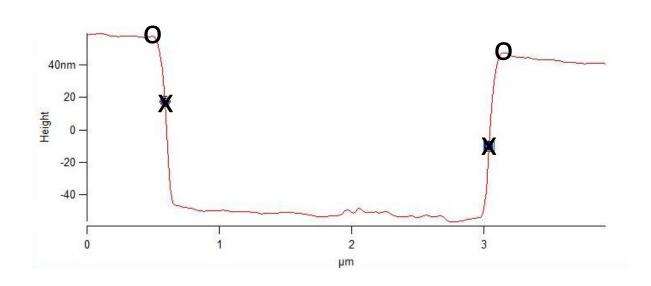


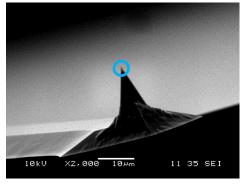


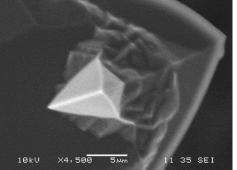


Width Measurements

- As depth increases, tips get broader
- Steep drop-offs look less sharp
- High aspect ratio tips are available









Application: Roughness

"The roughness" depends on the scale

- Choose measurement technique to match the feature scale of interest
 - AFM (nanoscale)
 - Stylus profilometry
 - 3D optical profilometry

What is the roughness of this landscape?



Michael Jeffords and Susan Post, University of Illinois Prairie Research Institute https://photojournalingm-s.smugmug.com/Colorado-and-Kansas/i-3tJ3DZk/A

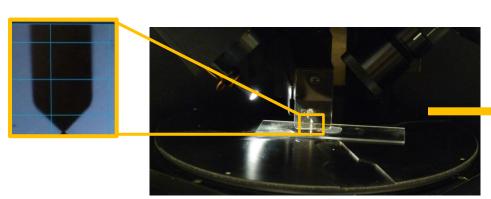


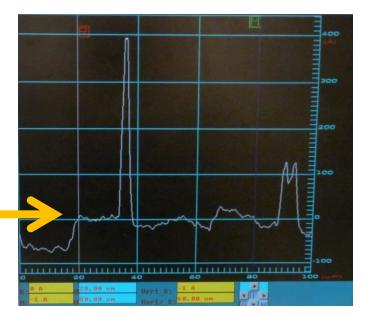
Complementary: Stylus Profilometry



2D stylus profilometry

(line profiles) (diamond tip)



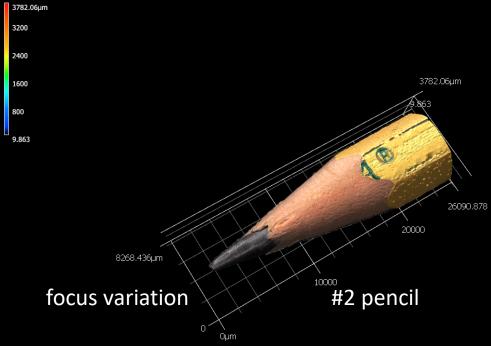




Complementary: Optical Profilometry

go.illinois.edu/MRL3DOpticalProfilometry







Qualitative Comparison

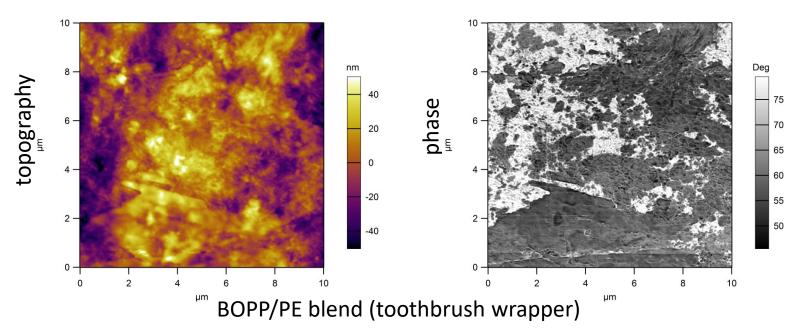
| | AFM | 2D Stylus Profilometry | 3D Optical Profilometry |
|---------------------|--------------------------------------|---------------------------|-------------------------|
| Vertical resolution | outstanding | ОК | ОК |
| Field of view | small | large | large |
| Data type | image | line | image |
| Max sample size | depends on instrument (~cm to large) | large | large |
| Max feature height | few μm | mm | mm |
| Force on sample | light | moderate | none |
| Speed | moderate | really fast | fast |



Mechanical Characterization

Visual impact of mechanical differences

- Phase (tapping mode)
- Force modulation, AM-FM, contact resonance, etc.
- Maps of quantitative measurement results (force mapping)

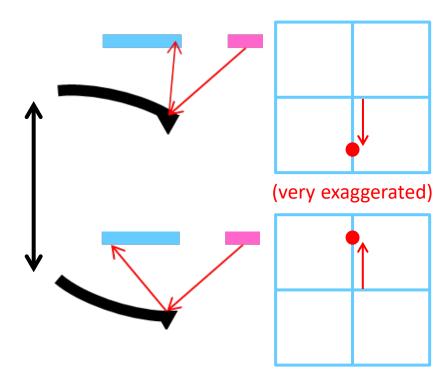




Tapping Mode Imaging: Phase

- Oscillating cantilever
- Tip—surface interactions affect oscillation
 - Cantilever driven sinusoidally to keep a constant amplitude
 - Dissipative interactions cause a phase lag (delay)
 - Viscous areas
 - Sticky areas

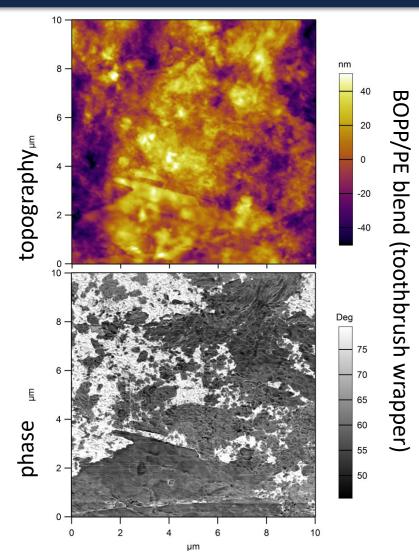
tip oscillates really fast (tens of kHz to MHz)





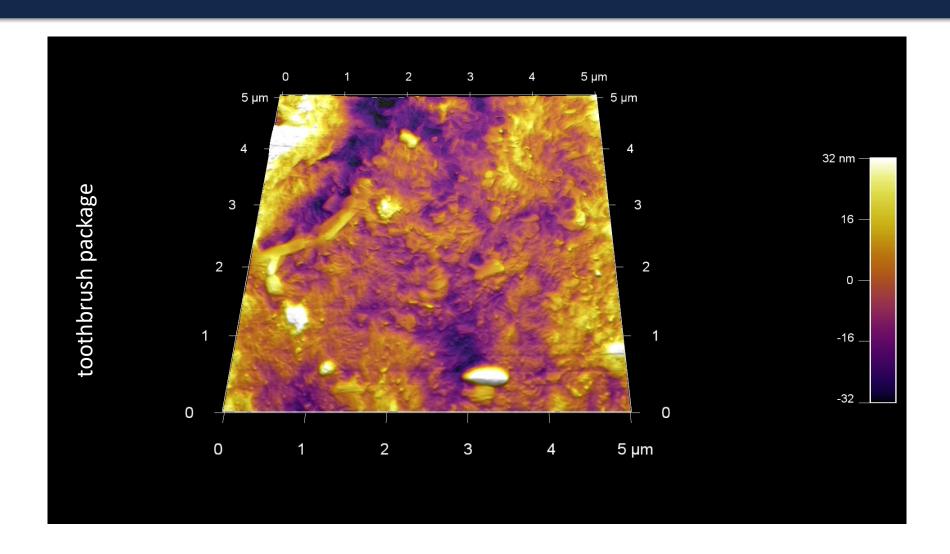
Phase (Qualitative)

- Tapping mode imaging
- Contrast in phase image shows differences in mechanical properties
 - Qualitative, not quantitative
 - Great for mixtures
 - Great for soft materials deposited on hard surfaces



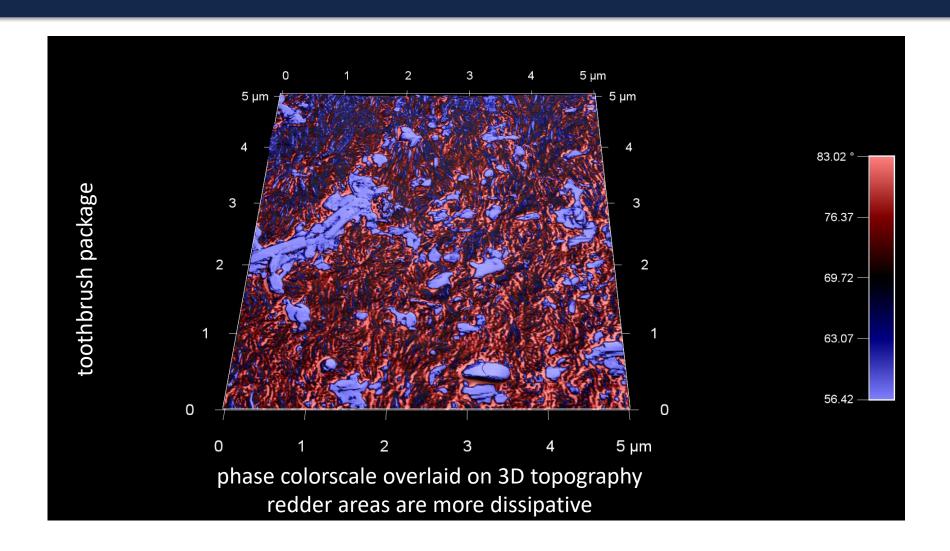


Topography



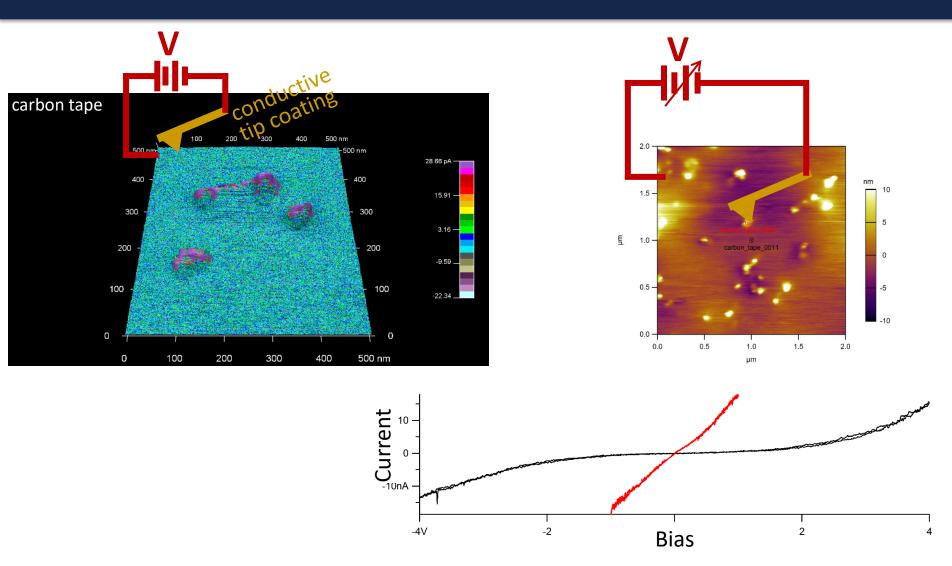


Topography with Colors from Phase





Common Application: Conductive AFM





Artifacts and Image Processing

 Recognize what is (or is not) informative about the sample

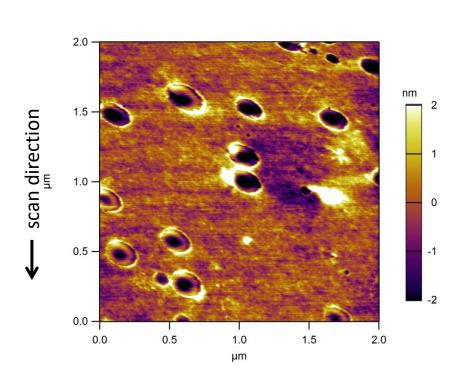
 Images may not always exactly represent the sample: sample drift, tip condition/geometry

- Display data in an informative way
 - Correct for sample tilt, etc.

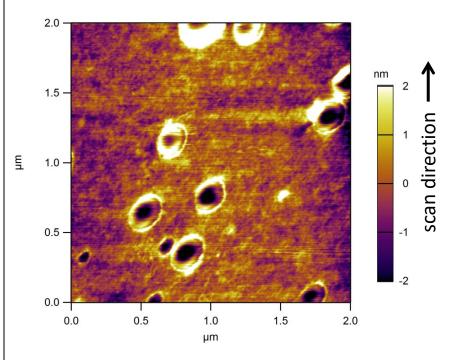


Sample Drift

Scanning downwards...



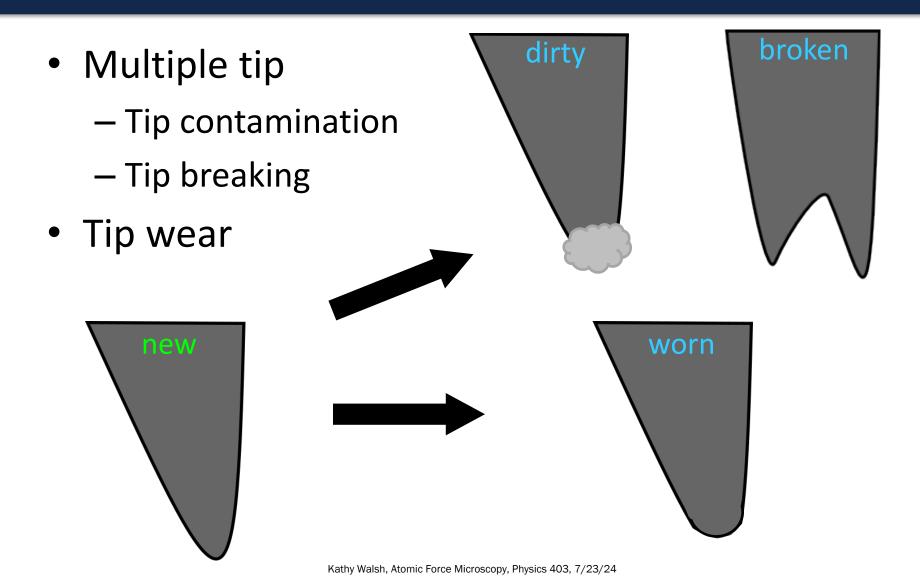
... then scanning upwards



chewing gum

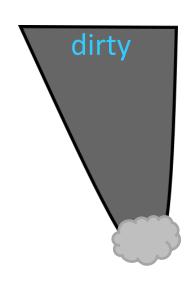


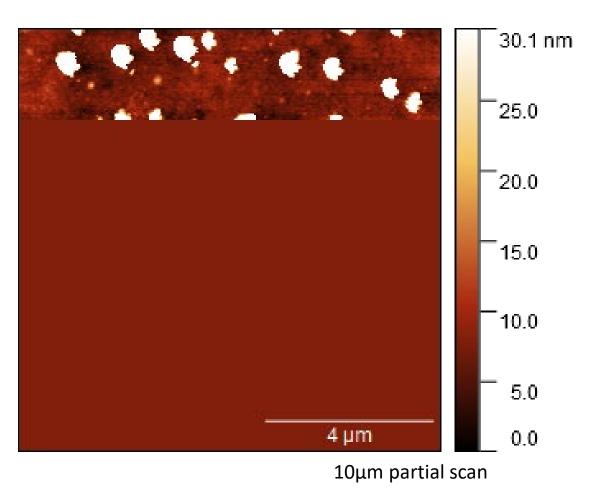
Tip Artifacts





Contaminated Tip

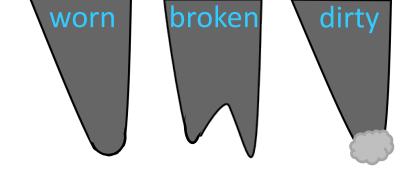






Tip Artifacts

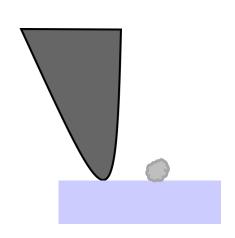
- Tip shape change
 - Multiple tip
 - Tip contamination
 - Tip breaking
 - Tip wear

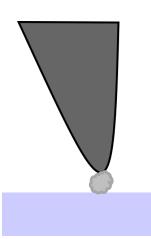


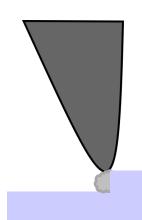
- Tip height change
 - Tip contamination
 - Tip wear

Line-by-Line Subtraction

- Difference from line to line
- Tip condition changes, curvature
- Polynomial subtraction







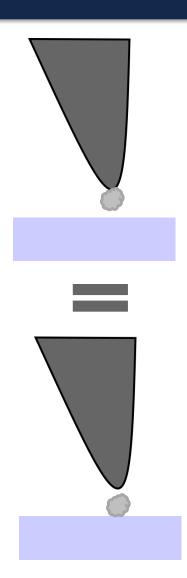
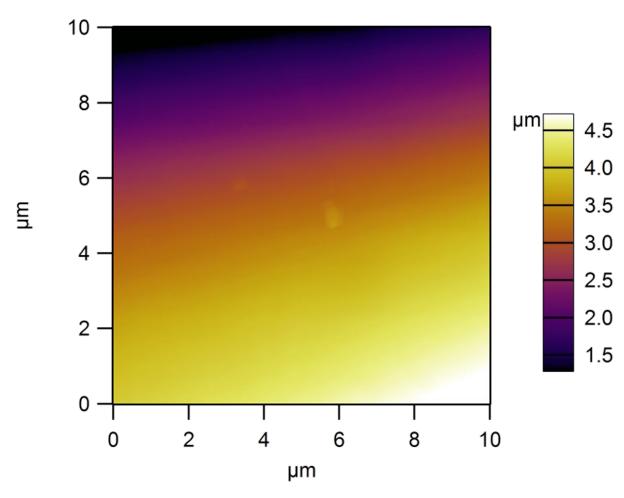




Image Processing

raw image

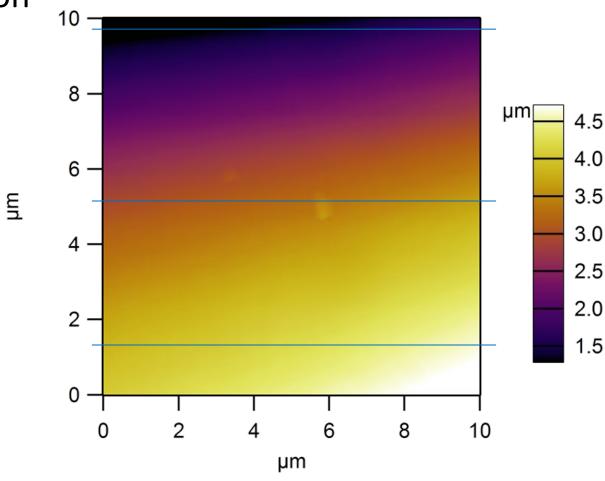


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Image Processing

line subtraction



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Image Processing

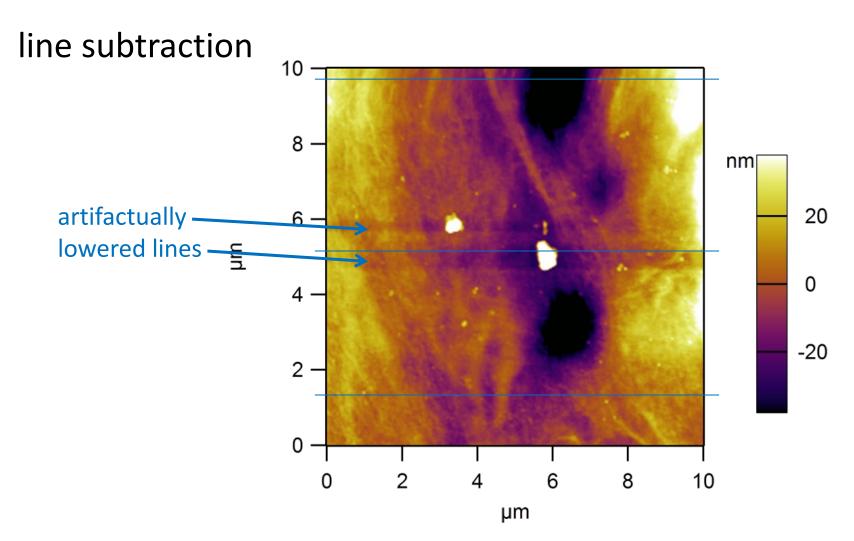


Image Processing

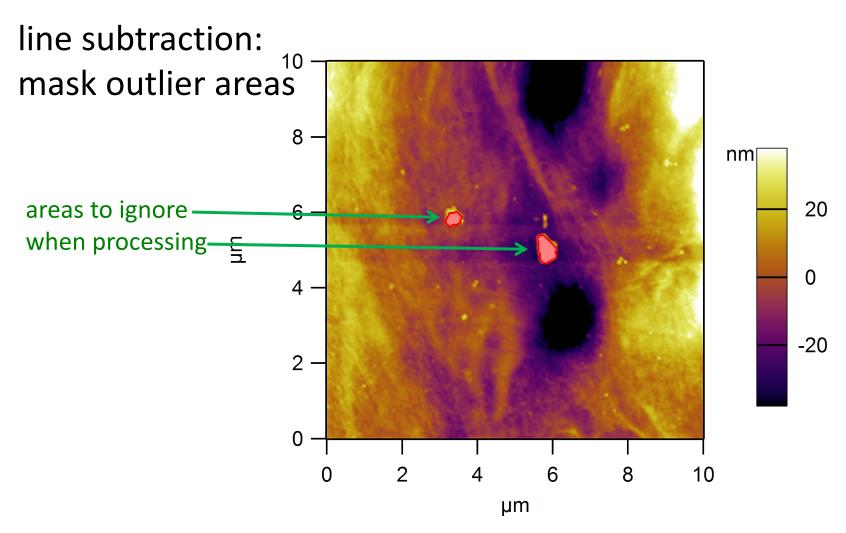
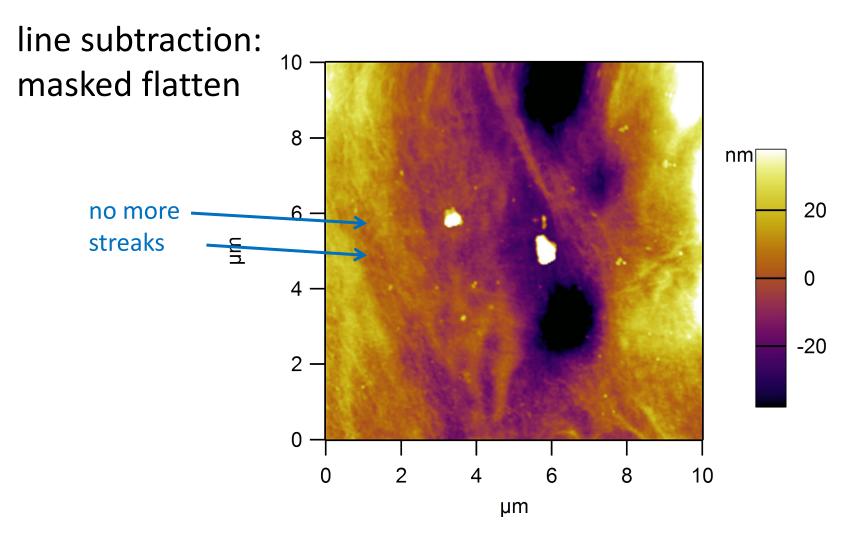
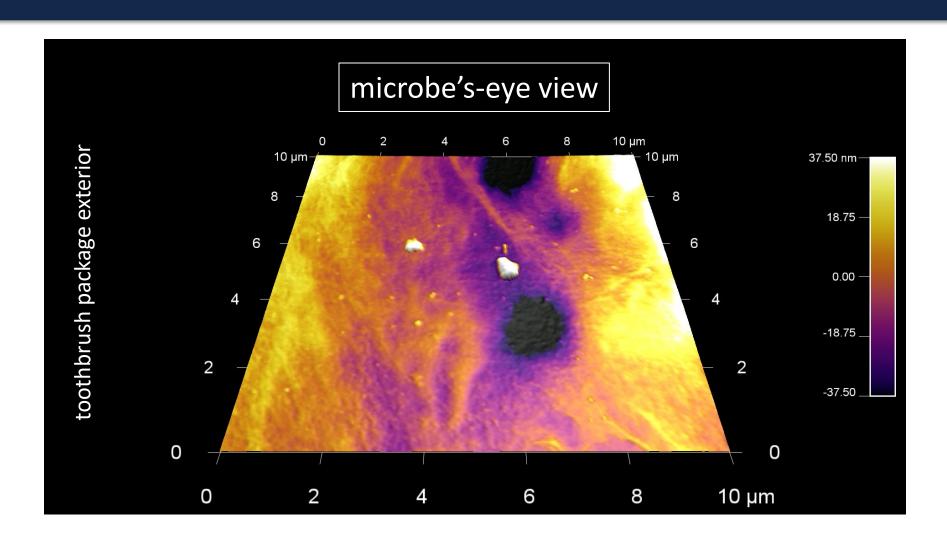


Image Processing

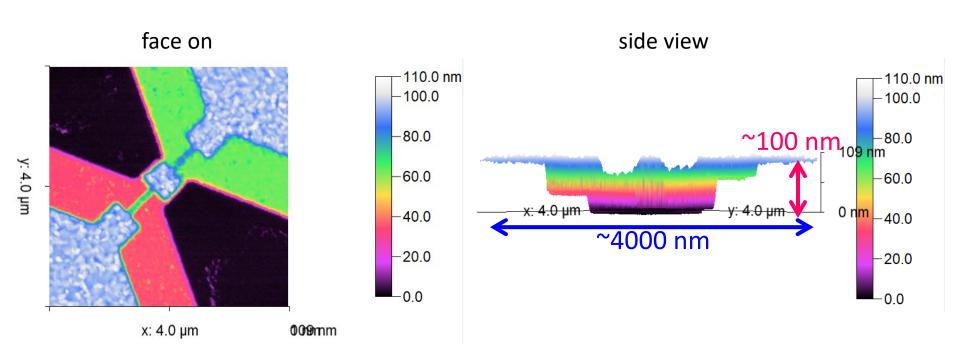




3D Display



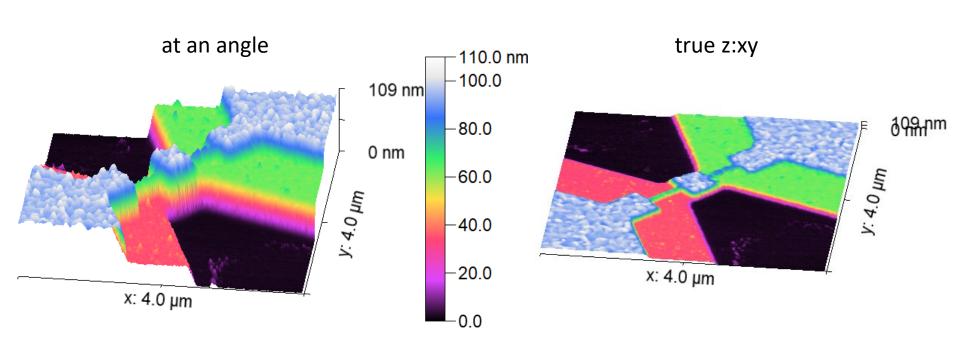
3D Display



raw data courtesy of Ale Baptista, Anton Paar Tosca 400 AFM

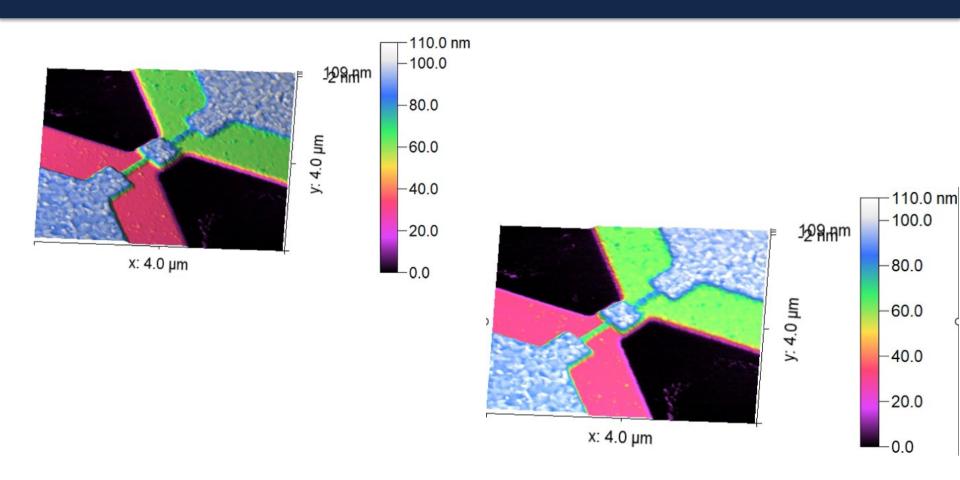
П

3D Display—z:xy



raw data courtesy of Ale Baptista, Anton Paar Tosca 400 AFM

3D Display—Lighting Angle



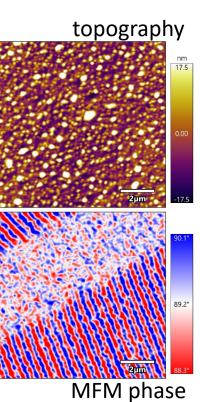
raw data courtesy of Ale Baptista, Anton Paar Tosca 400 AFM



Many Other Applications

- Nanolithography/nanomanipulation
- LFM (friction, lateral force microscopy)
- EFM (electrostatic force microscopy)
- KPFM (SKPM, Kelvin probe)
- MFM (magnetic force microscopy)
- PFM (piezoresponse force microscopy)

 ... and these generally don't need extra gear (except different tips)

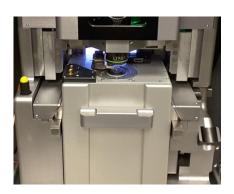




Attachments on the MRL AFMs

- ORCA Conductive AFM
- Scanning Microwave Impedance Microscopy (sMIM)
- Environmental Controller
- BioHeater
- PolyHeater (up to 300°C)
- Petri Dish Heater
- MFP-3D Leg Extenders
- blueDrive Photothermal Excitation
- Fast Force Mapping
- Dual-Gain ORCA Conductive AFM
- Piezoresponse Force Microscopy (HV-PFM)
- Contact Resonance Viscoelastic Mapping Mode
- AM-FM Viscoelastic Mapping Mode
- Scanning Tunneling Microscopy (STM)
- Air Temperature Controller (ATC)
- Droplet Cantilever Holder Kit





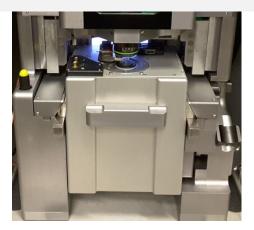




MRL AFMs—B12 MRL

Asylum Research MFP-3D-SA (2 of these) 15μm z range, 90μm x 90μm scan size Asylum Research Cypher 5μm z range, 30μm x 30μm scan size





0026 Supercon: Asylum Research MFP-3D-Bio on an inverted optical fluorescence microscope

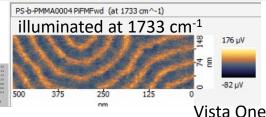




Related Instruments at MRL

Highly localized chemical information

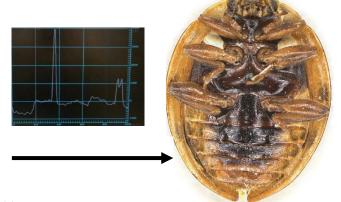
- Molecular Vista PiFM



- Photo-induced force microscopy and spectroscopy
- Horiba TERS/TEPL
 - Tip-enhanced Raman spectroscopy
- Neaspec Nano-IR
 - AFM + infrared

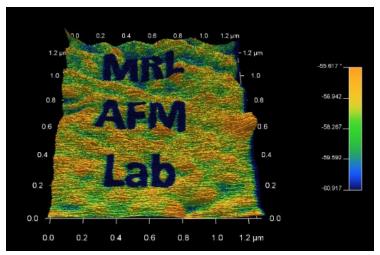
Profilometry

- Dektak stylus profilometer
- Keyence 3D optical profiler



Keep Learning

- MRL Webinar Series
 - go.illinois.edu/MRLYouTubeChannel
 - Basics of Atomic Force Microscopy (Kathy Walsh)
 - The Versatility of Nanomechanics with AFM (Jessica Spear)
 - 3D Optical Profilometry (Julio Soares and Kathy Walsh)
- Kathy Walsh, kawalsh@illinois.edu



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